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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q61200

Hiroshi OGAWA, *et al.*

Appln. No.: 09/810,230

Group Art Unit: 1774

Confirmation No.: 6907

Examiner: Camie S. THOMPSON

Filed: March 19, 2001

For: RADIATION IMAGE CONVERSION PANEL AND MANUFACTURING METHOD
THEREFOR

NOTICE OF APPEAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the final Office Action mailed March 3, 2004.

A check for the statutory fee of \$330.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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330.00 DP

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WASHINGTON OFFICE

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CUSTOMER NUMBER

Respectfully submitted,

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Date: September 3, 2004